

<b>Notice of References Cited</b>	Application/Control No. 10/656,086		Applicant(s)/Patent Under Reexamination PARK ET AL.	
	Examiner Laura S. Weiner		Art Unit 1745	Page 1 of 1

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*	C	US-7,223,500	05-2007	Noh et al.	429/307
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	K	US-			
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**NON-PATENT DOCUMENTS**

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